



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 3, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG753511490

LABORATORY GROWN DIAMOND

EMERALD CUT

9.83 X 7.03 X 4.60 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.10 CARATS

F

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

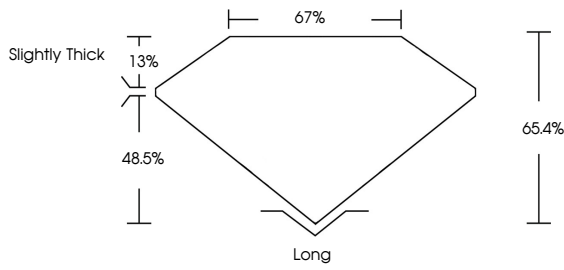
NONE

Inscription(s)

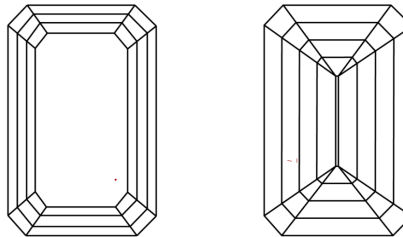
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG753511490

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

D	E	F	G	H	I	J	Faint	Very Light	Light
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³				
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included				

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Table

Girdle

Culet

Polish

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3.10 CARATS

F

VS 1

65.4%

67%

Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

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IGI



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